

# ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

Stylesheet Version v18.0

## Title of Invention

REMOVAL OF MEMS SACRIFICIAL LAYERS USING  
SUPERCRITICAL FLUID/CHEMICAL FORMULATIONS

Application Number : 10/782355  
Confirmation Number: 4186  
First Named Applicant: Michael Korzenski  
Attorney Docket Number: 020732-103.686CIP  
Art Unit: 2813  
Examiner: Tuan H. Nguyen  
Search string: ( 5789505 or 6149828 or 20030073302 ).pn



## US Patent Documents

**Note: Applicant is not required to submit a paper copy of cited US Patent Documents**

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
	1	5789505	1998-08-04	Wilkinson et al.			
	2	6149828	2000-11-21	Vaartstra			

## US Published Applications

**Note: Applicant is not required to submit a paper copy of cited US Published Applications**

init	Cite.No.	Pub. No.	Date	Applicant	Kind	Class	Subclass
	1	20030073302	2003-04-17	Huibers			

## Signature

Examiner Name	Date